

5300 PIXELS $\times$ 3 COLOR CCD LINEAR IMAGE SENSOR

The μ PD3797 is a color CCD (Charge Coupled Device) linear image sensor which changes optical images to electrical signal and has the function of color separation.

The μ PD3797 has 3 rows of 5300 pixels, and each row has a single-sided readout type of charge transfer register. And it has reset feed-through level clamp circuits, sample and hold circuits and voltage amplifiers. Therefore, it is suitable for 600 dpi/A4 color image scanners, color facsimiles and so on.

FEATURES

- Valid photocell : 5300 pixels $\times$ 3
- Photocell's pitch : 7 μ m
- Line spacing : 28 μ m (4 lines) Red line-Green line, Green line-Blue line
- Color filter : Primary colors (red, green and blue), pigment filter (with light resistance 10^7 lx $\cdot$ hour)
- Resolution : 24 dot/mm A4 (210 $\times$ 297 mm) size (shorter side)
600 dpi US letter (8.5" $\times$ 11") size (shorter side)
- Drive clock level : CMOS output under 5 V operation
- ★ • Data rate : 3 MHz MAX.
- Power supply : +12 V
- On-chip circuits : Reset feed-through level clamp circuits
Sample and hold circuits
Voltage amplifiers

ORDERING INFORMATION

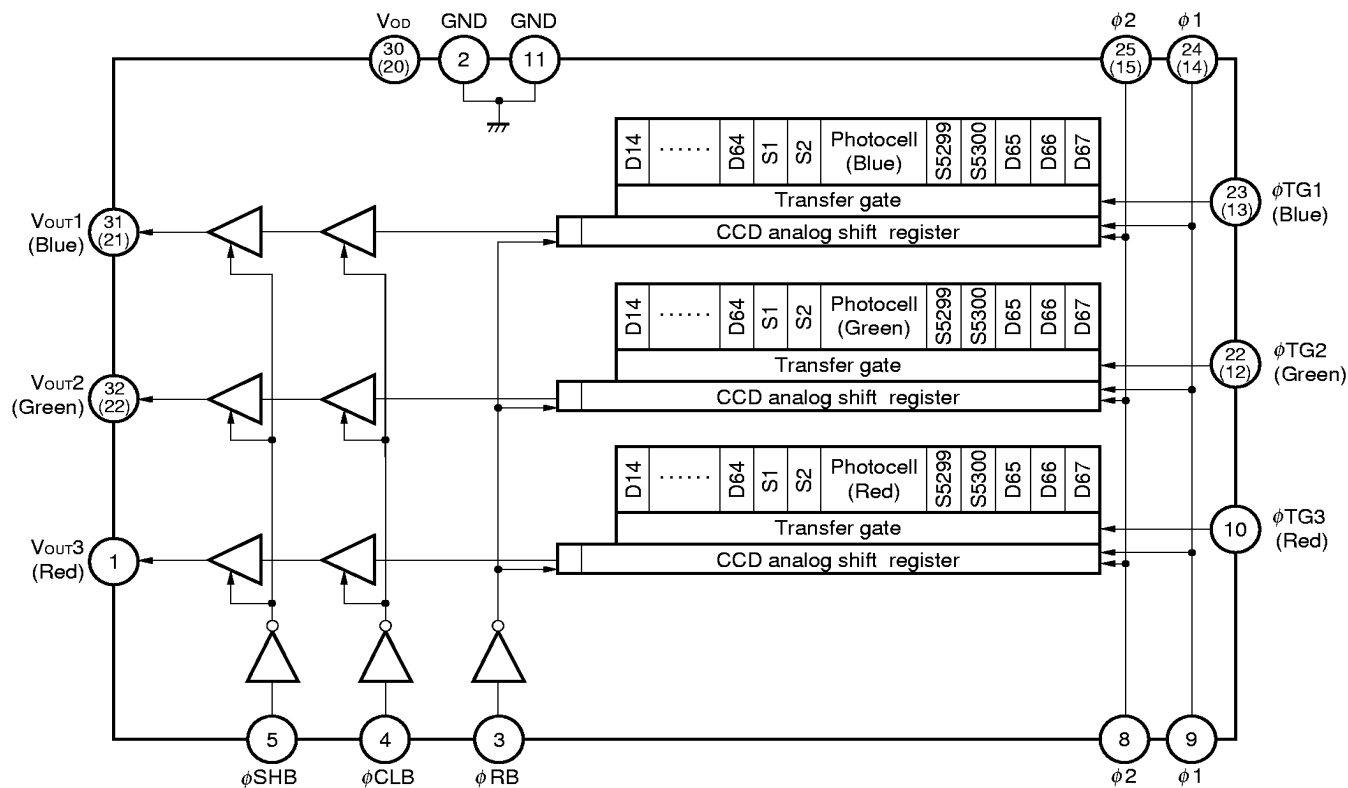
	Part Number	Package
★	μ PD3797CY	CCD linear image sensor 32-pin plastic DIP (400 mil)
	μ PD3797D	CCD linear image sensor 22-pin ceramic DIP (CERDIP) (400 mil)

The information in this document is subject to change without notice.

★ COMPARISON CHART

Item		μPD3797CY	μPD3797D
PIN CONFIGURATIONS	φTG2	Pin 22	Pin 12
	φTG1	Pin 23	Pin 13
	φ1	Pin 24	Pin 14
	φ2	Pin 25	Pin 15
	V _{OD}	Pin 30	Pin 20
	V _{OUT1}	Pin 31	Pin 21
	V _{OUT2}	Pin 32	Pin 22
	IC	4 pins of Internal connection (Pins 12, 13, 20, 21) are added. (Refer to PIN CONFIGURATIONS.)	—
	NC	6 pins of No connection (Pins 14 to 19) are added. (Refer to PIN CONFIGURATIONS.)	—
ABSOLUTE MAXIMUM RATINGS	storage temperature (°C)	−40 to +70	−40 to +100
PACKAGE DRAWINGS	package body material	plastic	ceramic
	package body length (mm)	55.2	48.6
	package body width (mm)	9.55	9.65
	lead length (mm) (from the bottom of package body)	4.21	4.68

★ BLOCK DIAGRAM

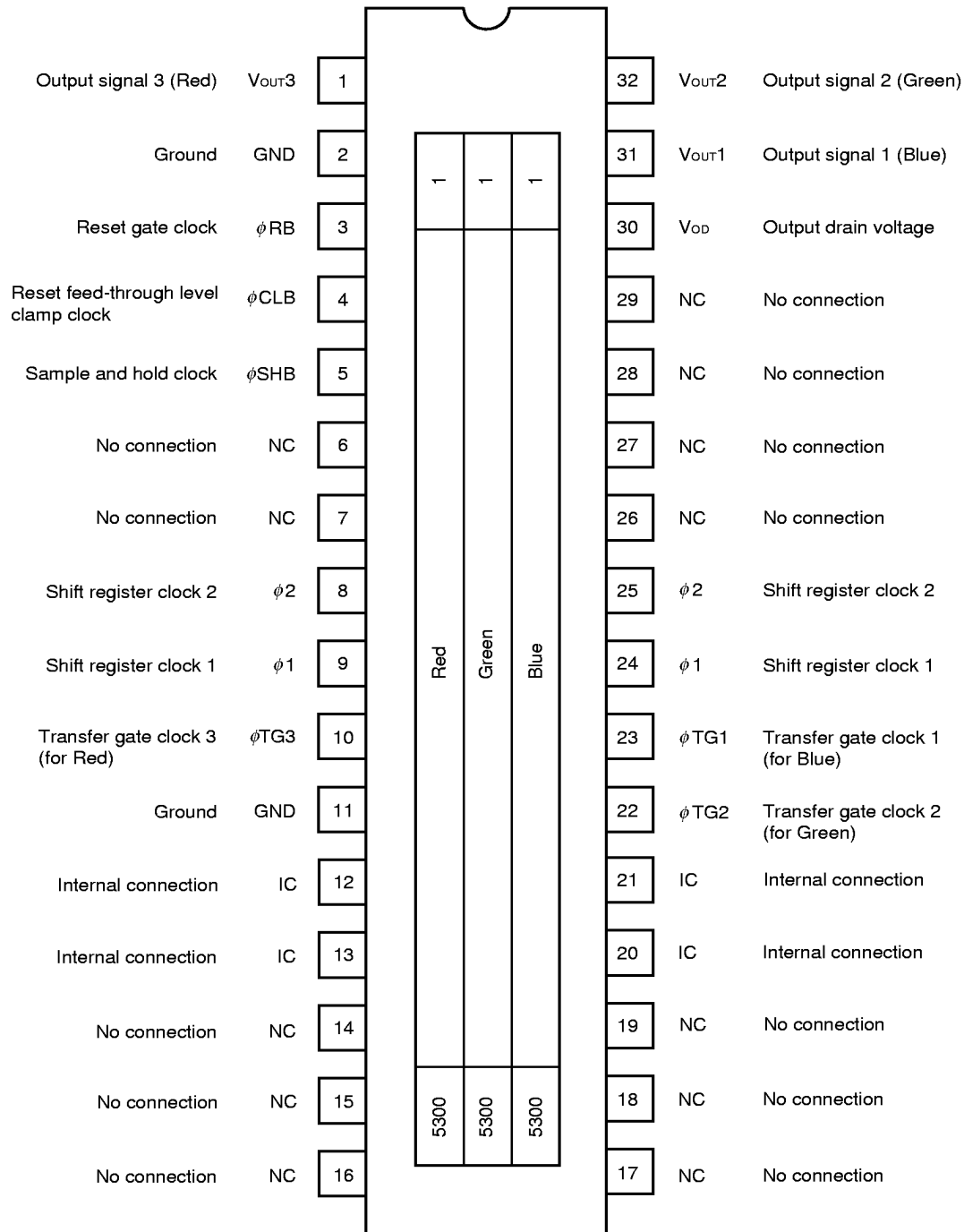


Remark μPD3797CY : Pin No. without ()
 μPD3797D : Pin No. in (), (only different pins)

PIN CONFIGURATIONS (Top View)

★ CCD linear image sensor 32-pin plastic DIP (400 mil)

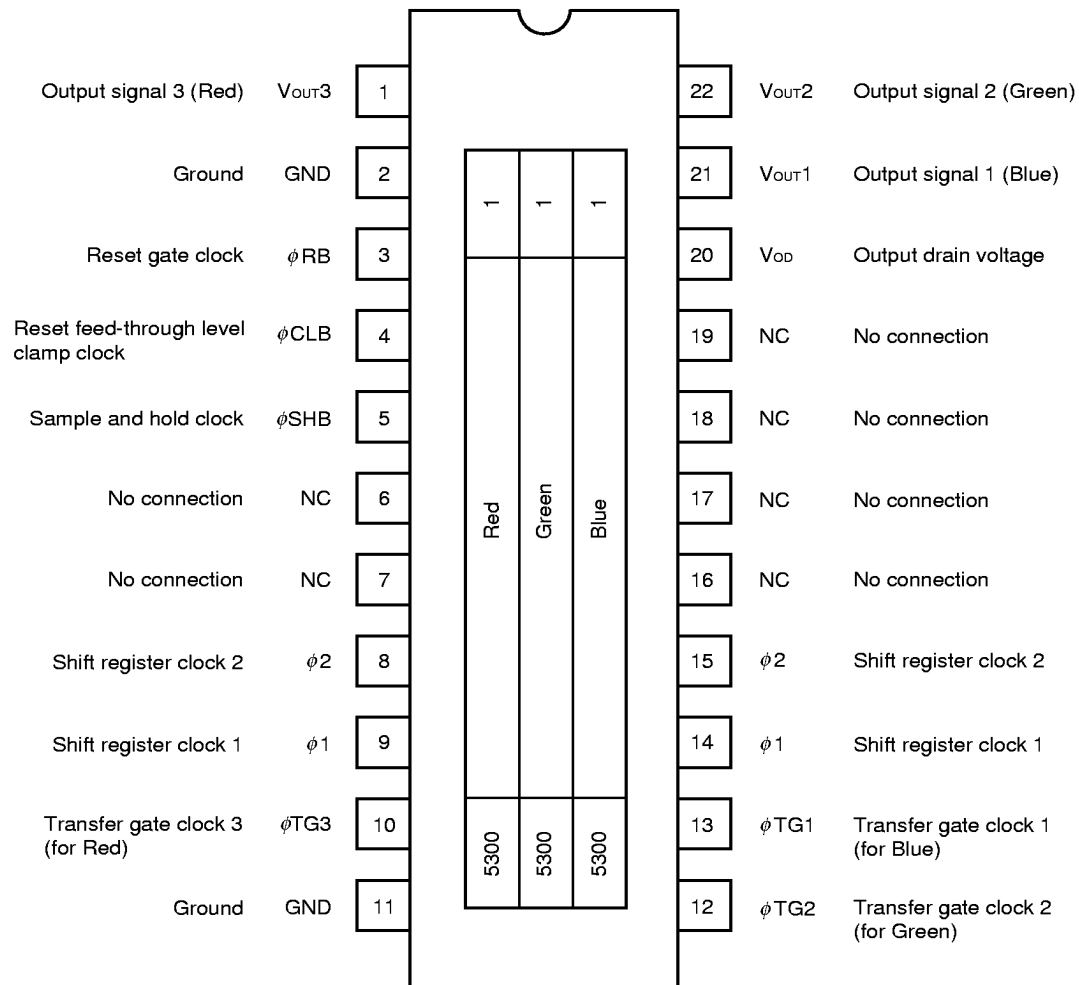
- μPD3797CY



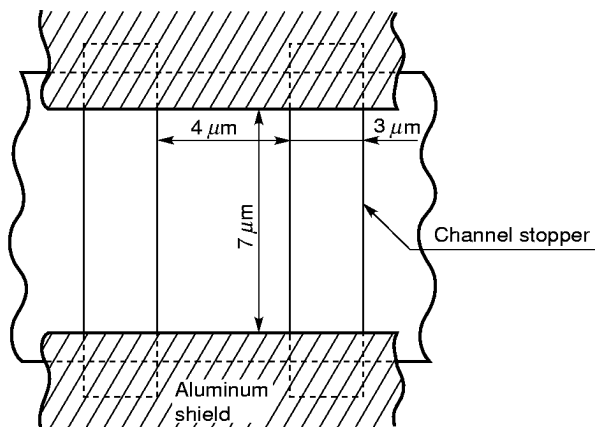
Caution Leave pins 12, 13, 20, 21 (IC) unconnected.

CCD linear image sensor 22-pin ceramic DIP (CERDIP) (400 mil)

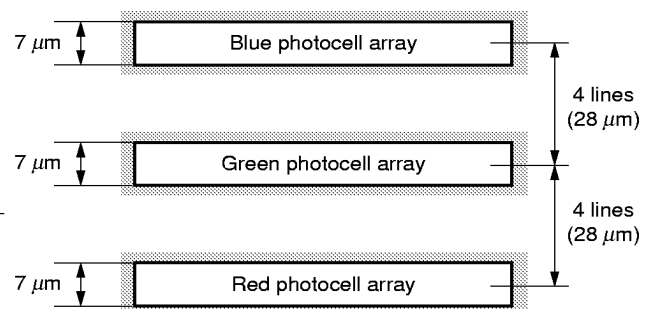
- μPD3797D



PHOTOCELL STRUCTURE DIAGRAM



PHOTOCELL ARRAY STRUCTURE DIAGRAM
(Line spacing)



ABSOLUTE MAXIMUM RATINGS ($T_A = +25\text{ }^{\circ}\text{C}$)

Parameter	Symbol	Ratings		Unit
Output drain voltage	V_{OD}	-0.3 to +15		V
Shift register clock voltage	$V_{\phi 1}, V_{\phi 2}$	-0.3 to +15		V
Reset gate clock voltage	$V_{\phi RB}$	-0.3 to +15		V
Sample and hold clock voltage	$V_{\phi SHB}$	-0.3 to +15		V
Reset feed-through level clamp clock voltage	$V_{\phi CLB}$	-0.3 to +15		V
Transfer gate clock voltage	$V_{\phi TG1}$ to $V_{\phi TG3}$	-0.3 to +15		V
Operating ambient temperature	T_A	-25 to +60		$^{\circ}\text{C}$
★ Storage temperature	T_{stg}	μ PD3797CY	-40 to +70	$^{\circ}\text{C}$
		μ PD3797D	-40 to +100	

Caution Exposure to **ABSOLUTE MAXIMUM RATINGS** for extended periods may affect device reliability; exceeding the ratings could cause permanent damage. The parameters apply independently.

RECOMMENDED OPERATING CONDITIONS ($T_A = +25\text{ }^{\circ}\text{C}$)

Parameter	Symbol	MIN.	TYP.	MAX.	Unit
Output drain voltage	V_{OD}	11.4	12.0	12.6	V
Shift register clock high level	$V_{\phi 1H}, V_{\phi 2H}$	4.5	5.0	5.5	V
Shift register clock low level	$V_{\phi 1L}, V_{\phi 2L}$	-0.3	0	+0.5	V
Reset gate clock high level	$V_{\phi RBH}$	4.5	5.0	5.5	V
Reset gate clock low level	$V_{\phi RBL}$	-0.3	0	+0.5	V
Sample and hold clock high level	$V_{\phi SHBH}$	4.5	5.0	5.5	V
Sample and hold clock low level	$V_{\phi SHBL}$	-0.3	0	+0.5	V
Reset feed-through level clamp clock high level	$V_{\phi CLBH}$	4.5	5.0	5.5	V
Reset feed-through level clamp clock low level	$V_{\phi CLBL}$	-0.3	0	+0.5	V
Transfer gate clock high level	$V_{\phi TG1H}$ to $V_{\phi TG3H}$	4.5	$V_{\phi 1H}$ Note	$V_{\phi 1H}$ Note	V
Transfer gate clock low level	$V_{\phi TG1L}$ to $V_{\phi TG3L}$	-0.3	0	+0.5	V
★ Data rate	$f_{\phi RB}$	—	1.0	3.0	MHz

Note When Transfer gate clock high level ($V_{\phi TG1H}$ to $V_{\phi TG3H}$) is higher than Shift register clock high level ($V_{\phi 1H}$), Image lag can increase.

ELECTRICAL CHARACTERISTICS

$\left(T_A = +25\text{ }^{\circ}\text{C}, V_{OD} = 12\text{ V}, \text{data rate (}f_{\phi RB}\text{)} = 1\text{ MHz, storage time} = 5.5\text{ ms,} \right.$
 $\left. \text{light source: 3200 K halogen lamp +C-500S (infrared cut filter, }t = 1\text{ mm), input signal clock} = 5\text{ V}_{PP} \right)$

Parameter		Symbol	Test Conditions	MIN.	TYP.	MAX.	Unit
Saturation voltage		V_{sat}		2.0	3.0	–	V
Saturation exposure	Red	SER			0.268		lx•s
	Green	SEG			0.294		lx•s
	Blue	SEB			0.492		lx•s
Photo response non-uniformity		PRNU	$V_{OUT} = 1.0\text{ V}$		6	20	%
Average dark signal		ADS	Light shielding		0.2	4.0	mV
Dark signal non-uniformity		DSNU	Light shielding		2.0	4.0	mV
Power consumption		P_W			400	700	mW
Output impedance		Z_O			0.5	1	k Ω
Response	Red	R_R		7.8	11.2	14.6	V/lx•s
	Green	R_G		7.1	10.2	13.3	V/lx•s
	Blue	R_B		4.2	6.1	8.0	V/lx•s
Image lag		IL	$V_{OUT} = 1.0\text{ V}$		3.0	10.0	%
Offset level Note1		V_{OS}		4.0	5.5	7.0	V
Output fall delay time Note2		t_d	$V_{OUT} = 1.0\text{ V}$		150		ns
Total transfer efficiency		TTE	$V_{OUT} = 1.0\text{ V,}$ data rate = 3 MHz	92	98		%
Response peak	Red				630		nm
	Green				540		nm
	Blue				460		nm
Dynamic range		DR1	V_{sat} / DSNU		1500		times
		DR2	V_{sat} / σ		3000		times
Reset feed-through noise Note1		RFTN	Light shielding, Non-sample and hold mode	–1000	–300	+500	mV
Random noise		σ	Light shielding	–	1.0	–	mV

Notes 1. Refer to **TIMING CHART 2**.

2. When the fall time of ϕ_1 (t_1) is the TYP. value (refer to **TIMING CHART 2**).

★ INPUT PIN CAPACITANCE ($T_A = +25\text{ }^\circ\text{C}$, $V_{OD} = 12\text{ V}$)

Parameter	Symbol	Pin name	Pin No.	MIN.	TYP.	MAX.	Unit
Shift register clock pin capacitance 1	$C_{\phi 1}$	$\phi 1$	9		400		pF
			24 (14)		400		pF
Shift register clock pin capacitance 2	$C_{\phi 2}$	$\phi 2$	8		400		pF
			25 (15)		400		pF
Reset gate clock pin capacitance	$C_{\phi RB}$	ϕRB	3		15		pF
Sample and hold clock pin capacitance	$C_{\phi SHB}$	ϕSHB	5		15		pF
Reset feed-through level clamp clock pin capacitance	$C_{\phi CLB}$	ϕCLB	4		15		pF
Transfer gate clock pin capacitance	$C_{\phi TG}$	$\phi TG1$	23 (13)		100		pF
		$\phi TG2$	22 (12)		100		pF
		$\phi TG3$	10		100		pF

Remarks 1. μ PD3797CY: Pin No. without ()

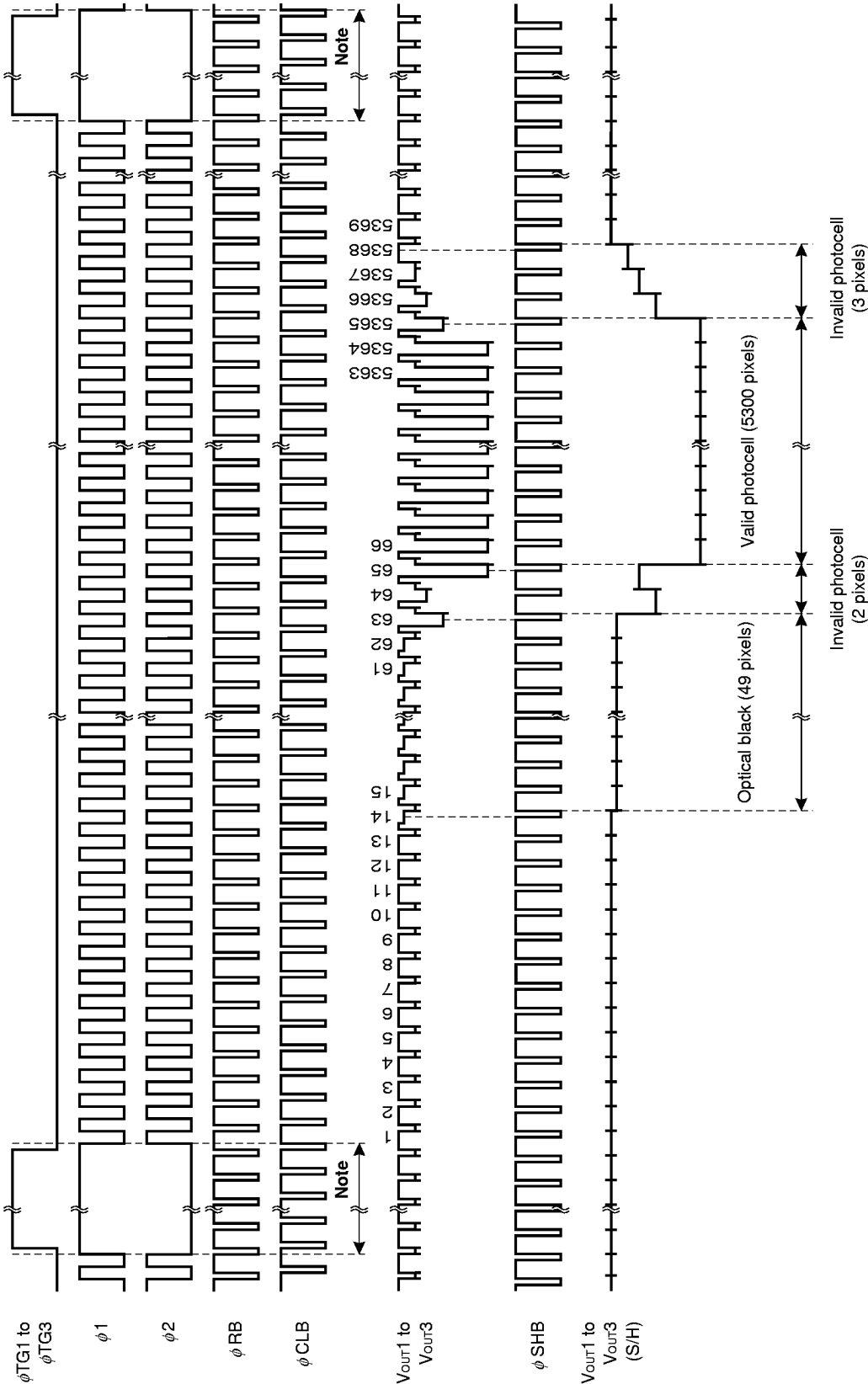
μ PD3797D : Pin No. in (), (only different pins)

2. Pins 9 and 24 (14): $\phi 1$, 8 and 25 (15): $\phi 2$ are each connected inside of the device.

SAMPLE AND HOLD FUNCTION

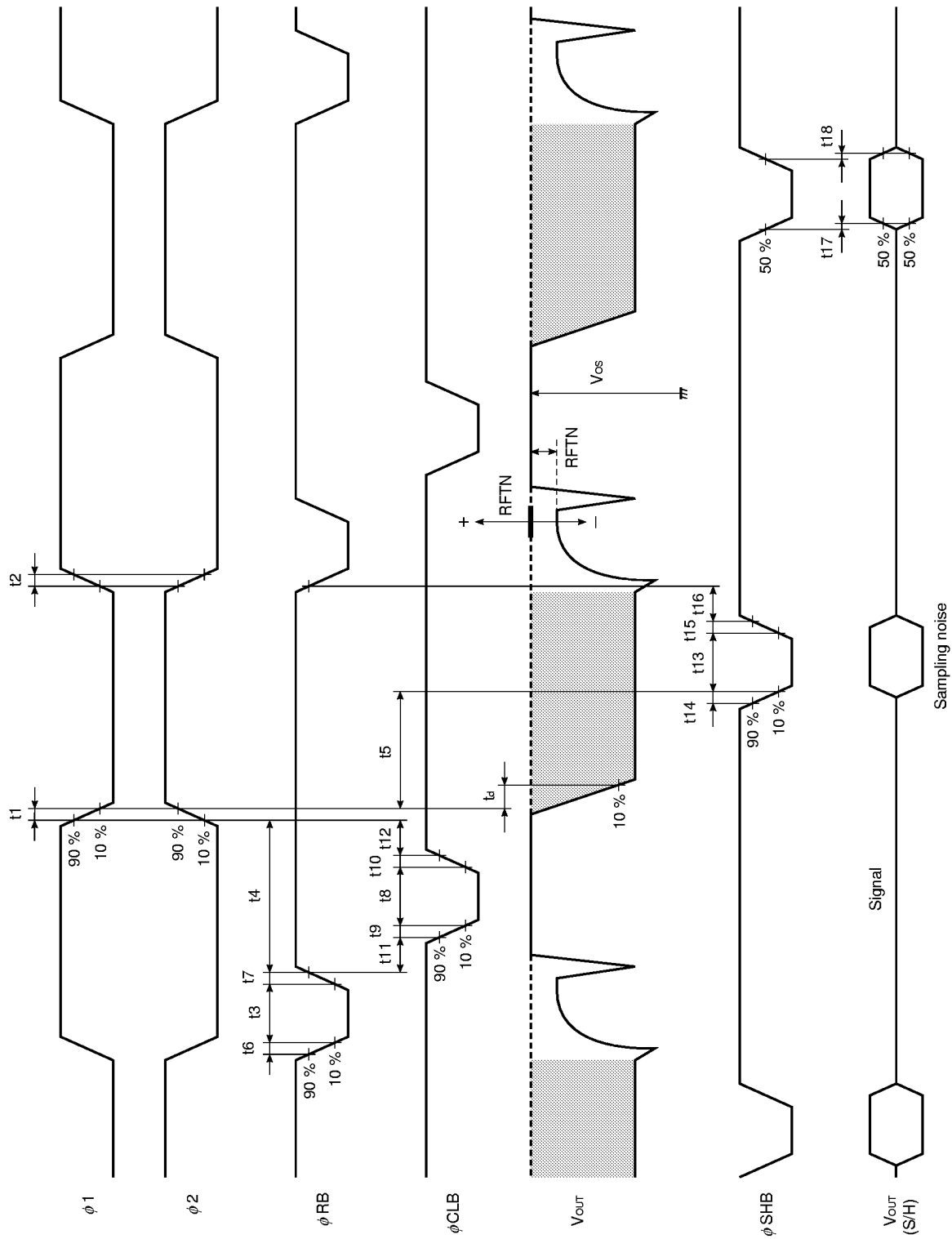
ϕSHB	Output type
Pulse	Sample and hold type
DC low level	Non-sample and hold type
DC high level	Prohibited

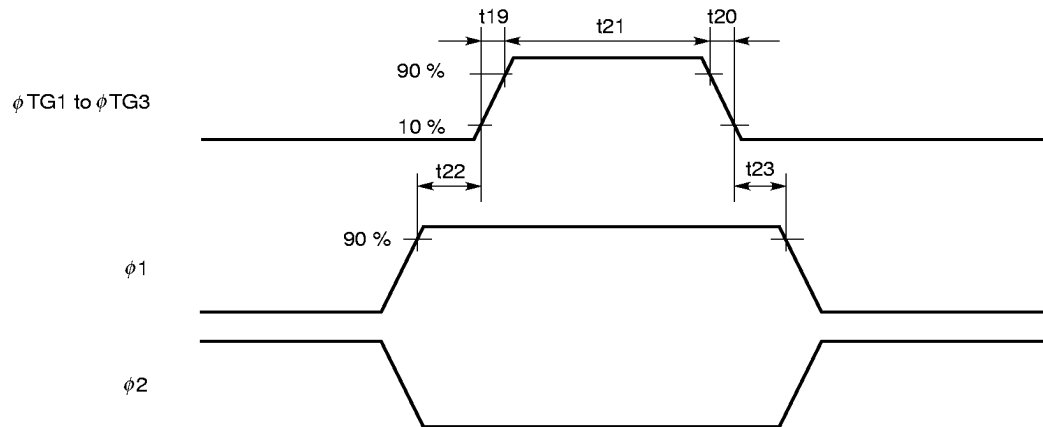
TIMING CHART 1 (for each color)



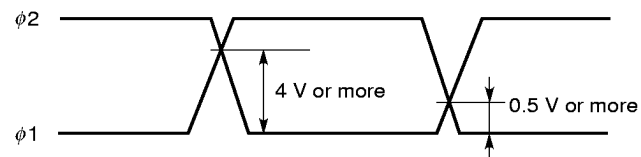
Note Input the ϕ_{RB} and ϕ_{CLB} pulses continuously during this period. And also input the ϕ_{SHB} pulse when the on-chip sample and hold function is used.

TIMING CHART 2 (for each color)



ϕ TG1 to ϕ TG3, ϕ 1, ϕ 2 TIMING CHART

Symbol	MIN.	TYP.	MAX.	Unit
t1, t2	0	25		ns
t3	30	50		ns
t4	60	250		ns
t5	60	200		ns
t6, t7	0	25		ns
t8	40	100		ns
t9, t10	0	25		ns
t11	10	50		ns
t12	0	5		ns
t13	40	150		ns
t14, t15	0	25		ns
t16	0	30		ns
t17, t18	0	10	—	ns
t19, t20	0	50		ns
t21	3000	10000		ns
t22, t23	900	1000		ns

 ϕ 1, ϕ 2 cross points

Remark Adjust cross points of ϕ 1 and ϕ 2 with input resistance of each pin.

DEFINITIONS OF CHARACTERISTIC ITEMS

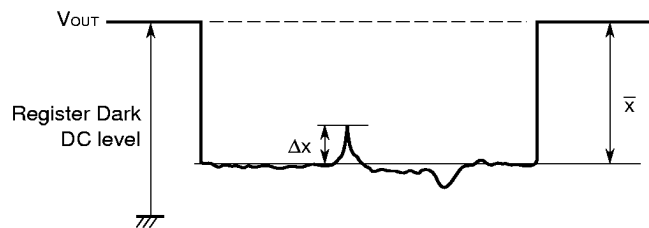
1. Saturation voltage: V_{sat}
Output signal voltage at which the response linearity is lost.
2. Saturation exposure: SE
Product of intensity of illumination (I_x) and storage time (s) when saturation of output voltage occurs.
3. Photo response non-uniformity: PRNU
The output signal non-uniformity of all the valid pixels when the photosensitive surface is applied with the light of uniform illumination. This is calculated by the following formula.

$$\text{PRNU (\%)} = \frac{\Delta x}{\bar{x}} \times 100$$

Δx : maximum of $|x_j - \bar{x}|$

$$\bar{x} = \frac{\sum_{j=1}^{5300} x_j}{5300}$$

x_j : Output voltage of valid pixel number j



4. Average dark signal: ADS
Average output signal voltage of all the valid pixels at light shielding. This is calculated by the following formula.

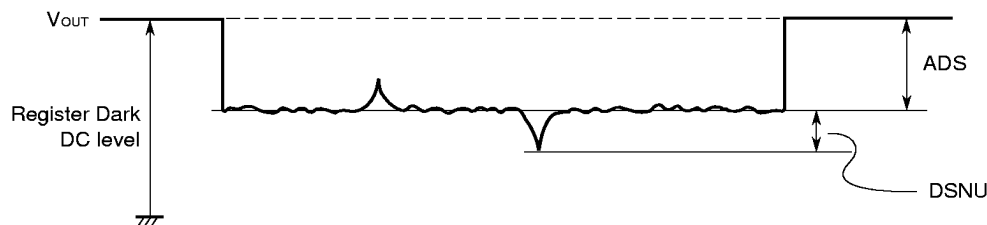
$$\text{ADS (mV)} = \frac{\sum_{j=1}^{5300} d_j}{5300}$$

d_j : Dark signal of valid pixel number j

5. Dark signal non-uniformity: DSNU
Absolute maximum of the difference between ADS and voltage of the highest or lowest output pixel of all the valid pixels at light shielding. This is calculated by the following formula.

$$\text{DSNU (mV)} : \text{maximum of } |d_j - \text{ADS}|_{j=1 \text{ to } 5300}$$

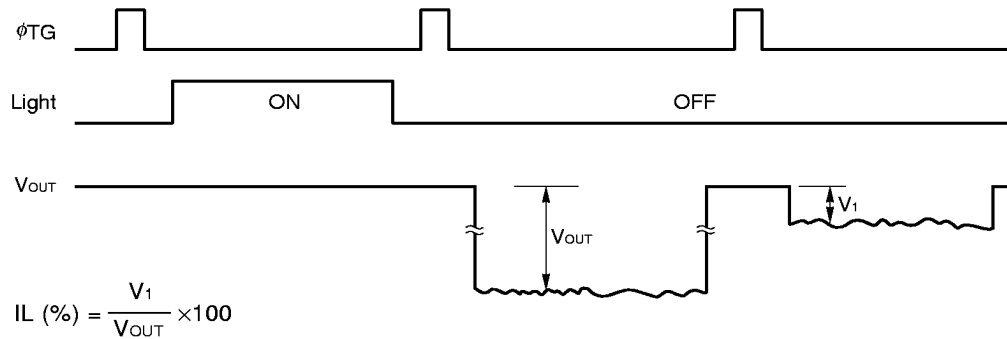
d_j : Dark signal of valid pixel number j



6. Output impedance: Z_o
Impedance of the output pins viewed from outside.

7. Response: R
Output voltage divided by exposure ($I_x \cdot s$).
Note that the response varies with a light source (spectral characteristic).

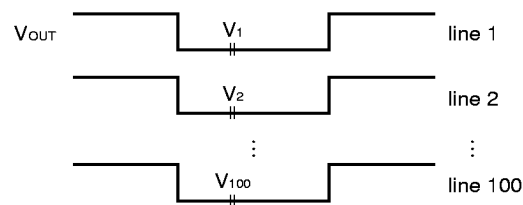
8. Image Lag: IL
The rate between the last output voltage and the next one after read out the data of a line.



9. Random noise: σ
Random noise σ is defined as the standard deviation of a valid pixel output signal with 100 times (=100 lines) data sampling at dark (light shielding).

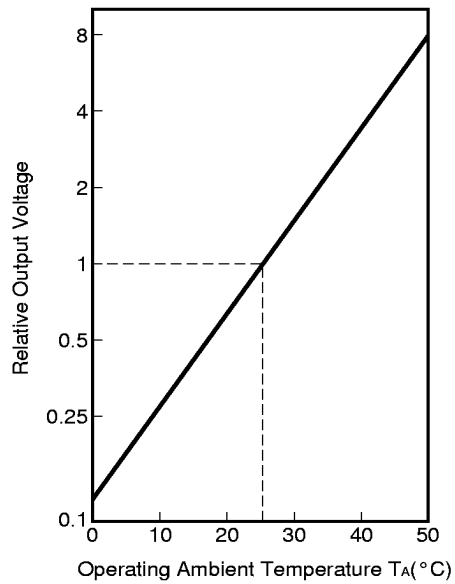
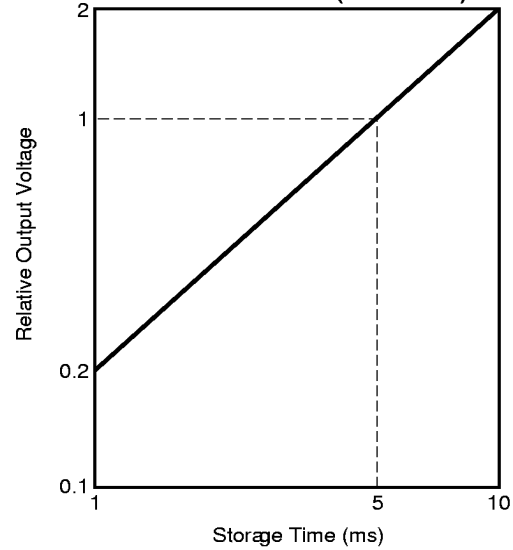
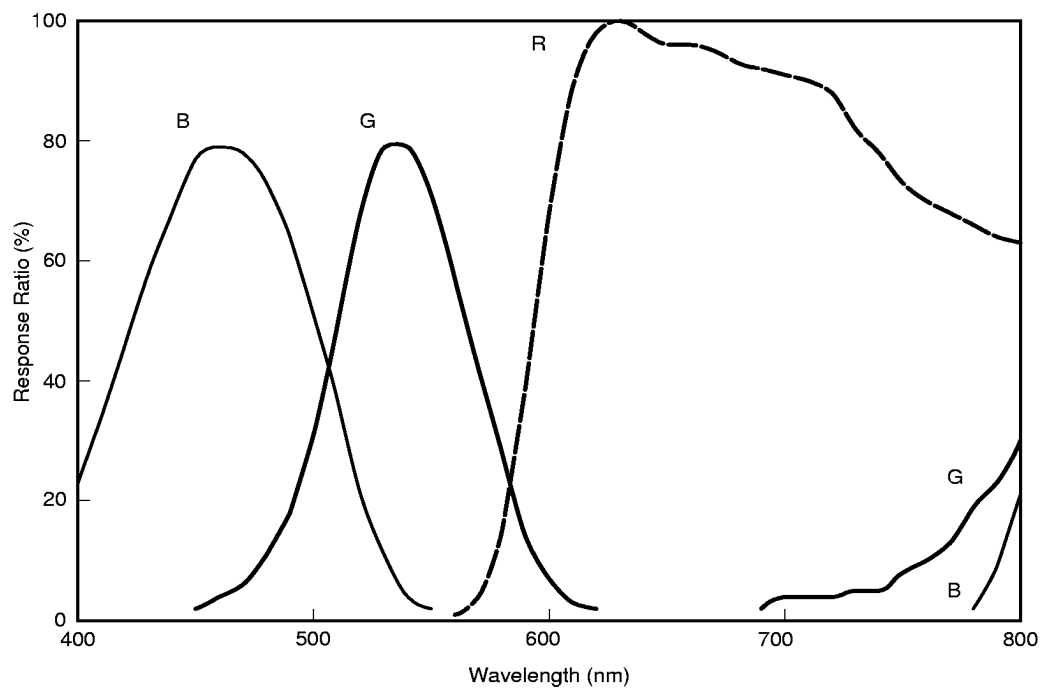
$$\sigma (mV) = \sqrt{\frac{\sum_{i=1}^{100} (V_i - \bar{V})^2}{100}}, \quad \bar{V} = \frac{1}{100} \sum_{i=1}^{100} V_i$$

V_i : A valid pixel output signal among all of the valid pixels for each color



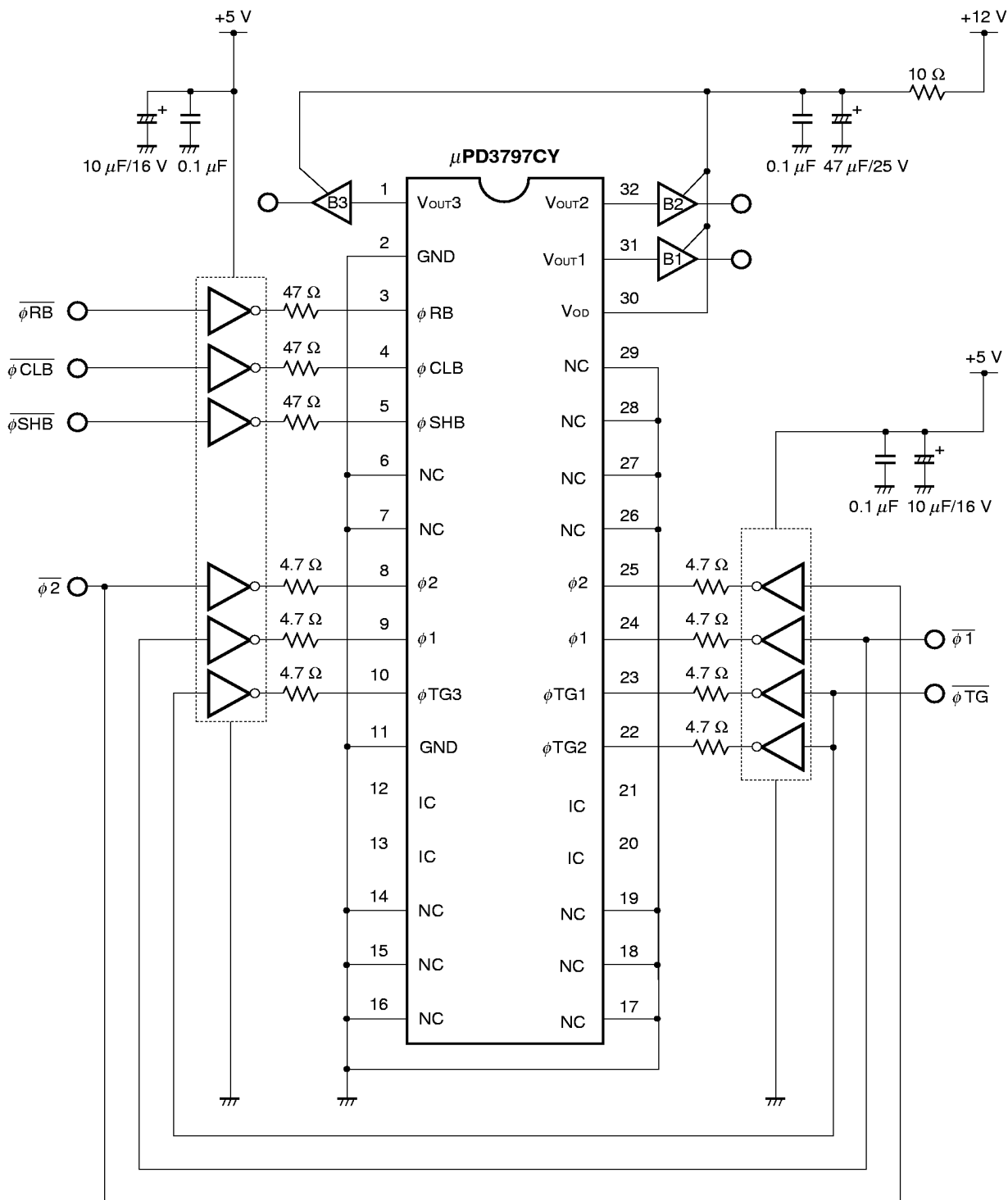
This is measured by the DC level sampling of only the signal level, not by CDS (Correlated Double Sampling).

STANDARD CHARACTERISTIC CURVES

DARK OUTPUT TEMPERATURE
CHARACTERISTICSTORAGE TIME OUTPUT VOLTAGE
CHARACTERISTIC ($T_A = +25^\circ\text{C}$)TOTAL SPECTRAL RESPONSE CHARACTERISTICS
(without infrared cut filter) ($T_A = +25^\circ\text{C}$)

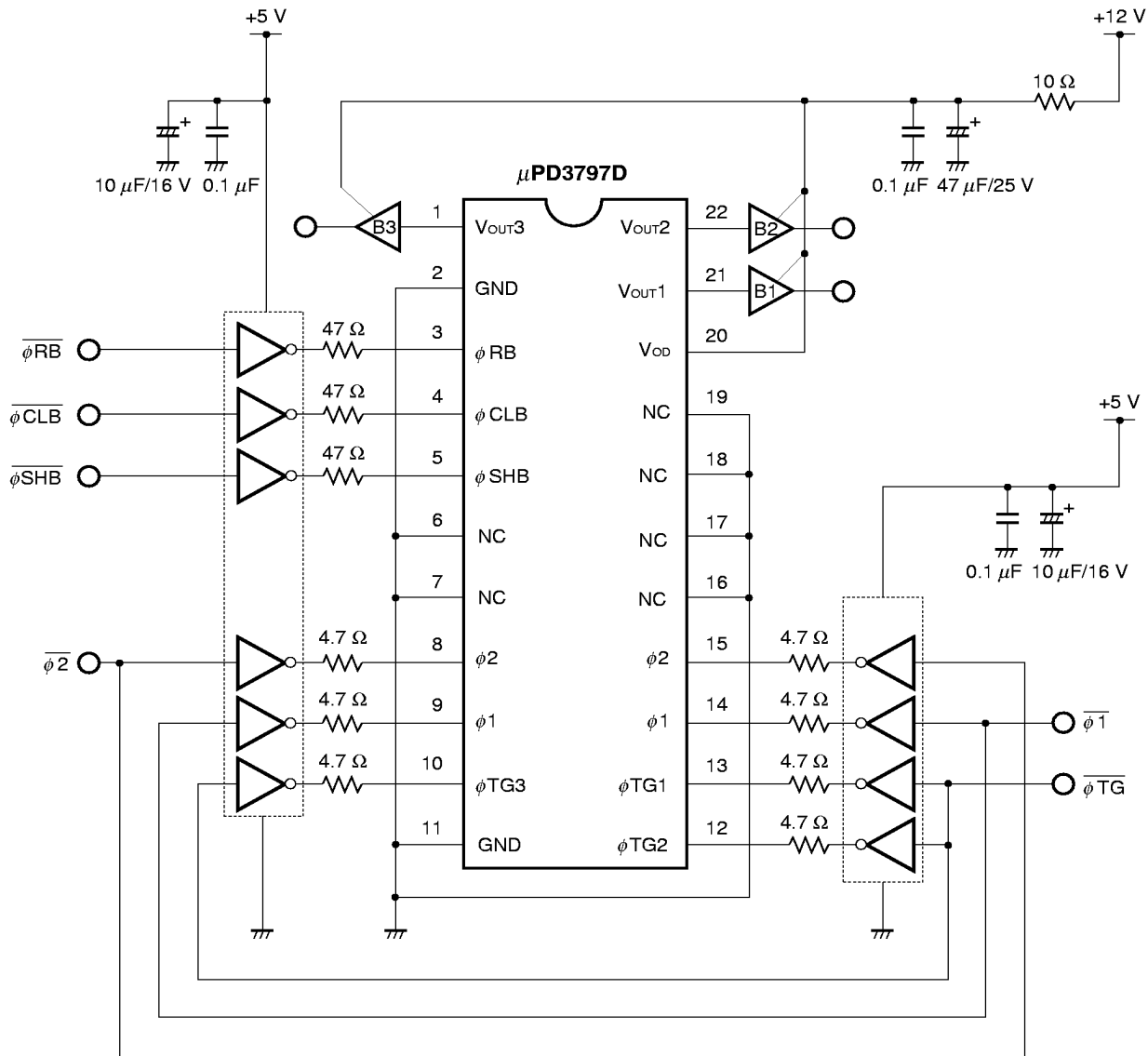
APPLICATION CIRCUIT EXAMPLES

- ★ • μPD3797CY

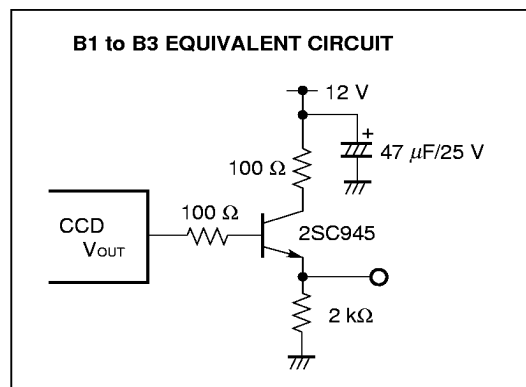


Caution Leave pins 12, 13, 20, 21 (IC) unconnected.

• μ PD3797D



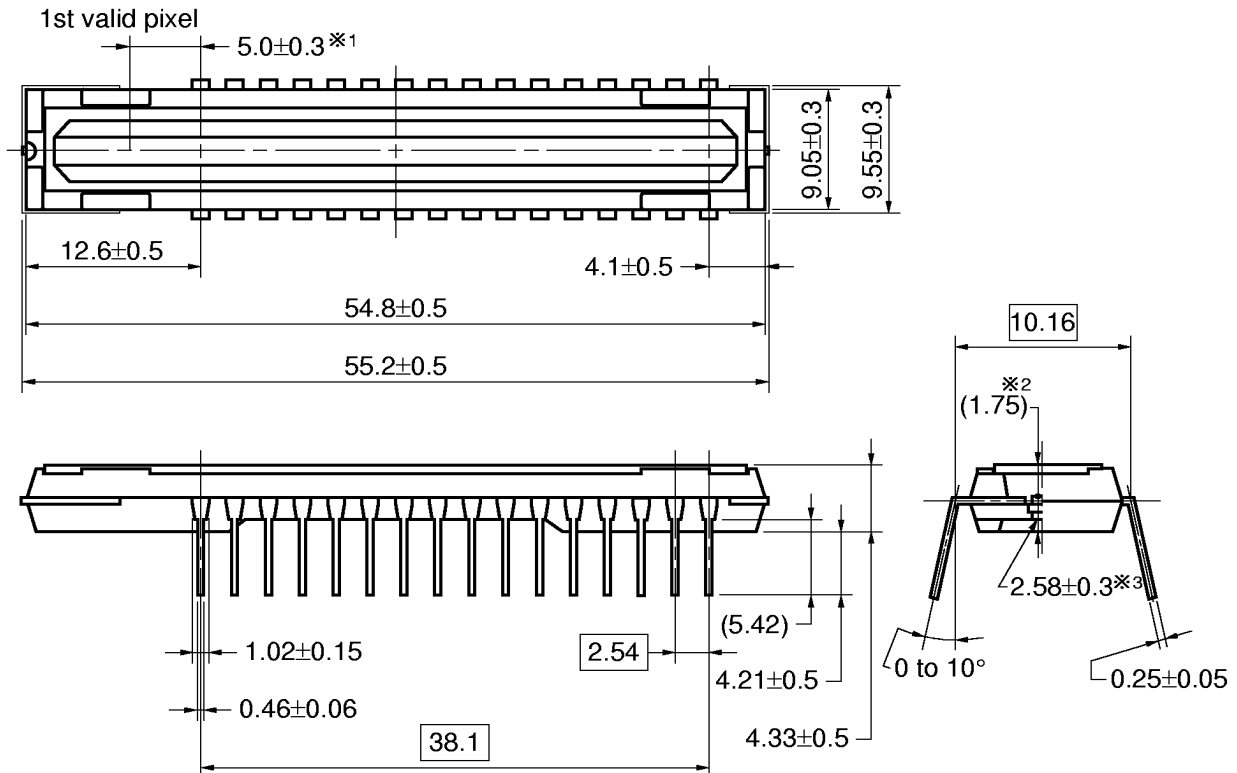
- Remarks**
1. When internal sample and hold circuit of the μ PD3797 is not necessary, connect pin 5 (ϕ SHB) to GND.
 2. The inverters shown in the application circuit examples are the 74HC04.



PACKAGE DRAWINGS

★ CCD LINEAR IMAGE SENSOR 32PIN PLASTIC DIP (400 mil)

(Unit : mm)



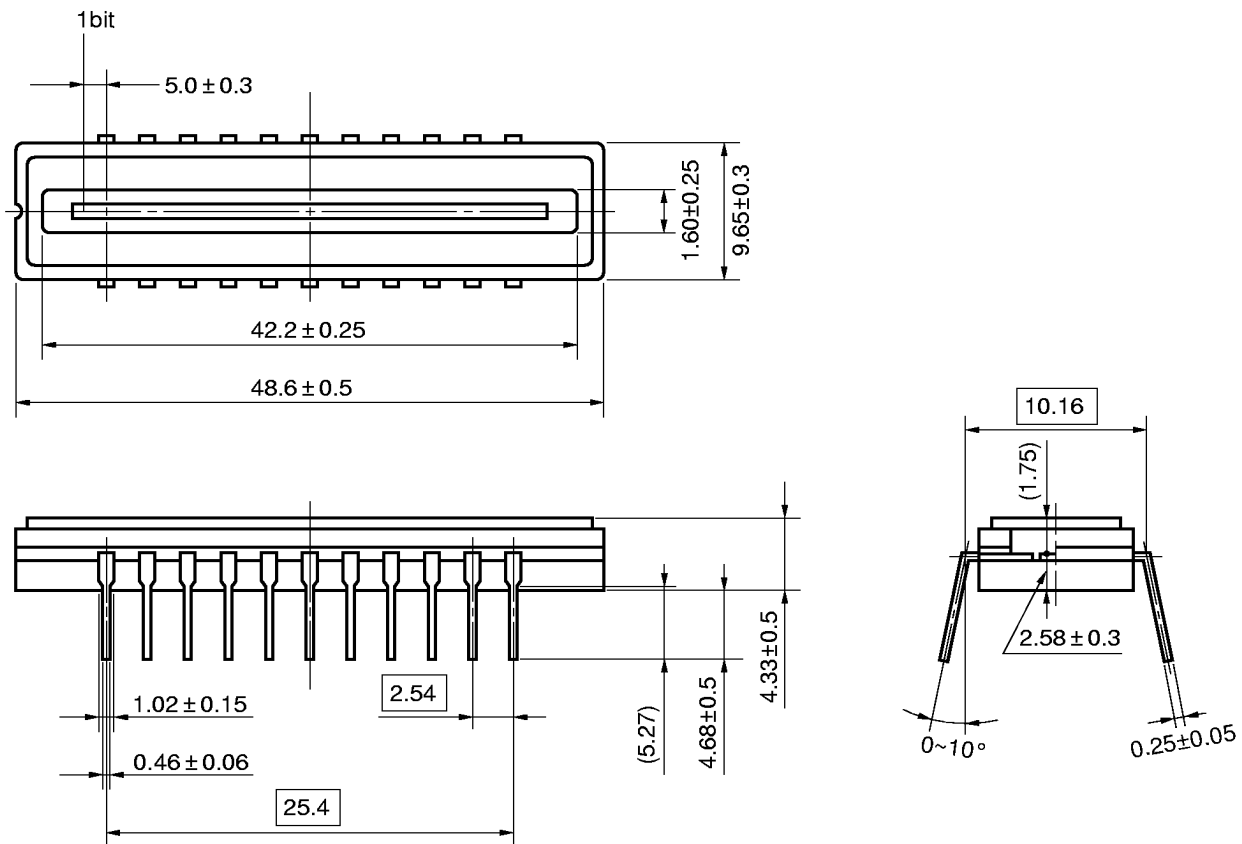
Name	Dimensions	Refractive index
Glass cap	$52.2 \times 6.4 \times 0.7$	1.5

- ※1 1st valid pixel ↔ Center of pin 1
 ※2 Photosensitive surface of CCD chip ↔ Top of glass cap (reference)
 ※3 Photosensitive surface of CCD chip ↔ Bottom of package

32C-1CCD-PKG

CCD LINEAR IMAGE SENSOR 22 PIN CERAMIC DIP(CERDIP)(400mil)

(Unit : mm)



Name	Dimensions	Refractive index
Glass cap	47.5×9.25×0.7	1.5

22D-1CCD-PKG9

RECOMMENDED SOLDERING CONDITIONS

When soldering these products, it is highly recommended to observe the conditions as shown below.

If other soldering processes are used, or if the soldering is performed under different conditions, please make sure to consult with our sales offices.

For more details, refer to our document "**Semiconductor Device Mounting Technology Manual**"(C10535E).

Type of Through-hole Device

★

μ PD3797CY : CCD linear image sensor 32-pin plastic DIP (400 mil)

μ PD3797D : CCD linear image sensor 22-pin ceramic DIP (CERDIP) (400 mil)

Process	Conditions
Partial heating method	Pin temperature: 260 °C or below, Heat Time: 10 seconds or less (per pin)

[MEMO]

[MEMO]

[MEMO]

NOTES FOR CMOS DEVICES

① PRECAUTION AGAINST ESD FOR SEMICONDUCTORS

Note: Strong electric field, when exposed to a MOS device, can cause destruction of the gate oxide and ultimately degrade the device operation. Steps must be taken to stop generation of static electricity as much as possible, and quickly dissipate it once, when it has occurred. Environmental control must be adequate. When it is dry, humidifier should be used. It is recommended to avoid using insulators that easily build static electricity. Semiconductor devices must be stored and transported in an anti-static container, static shielding bag or conductive material. All test and measurement tools including work bench and floor should be grounded. The operator should be grounded using wrist strap. Semiconductor devices must not be touched with bare hands. Similar precautions need to be taken for PW boards with semiconductor devices on it.

② HANDLING OF UNUSED INPUT PINS FOR CMOS

Note: No connection for CMOS device inputs can be cause of malfunction. If no connection is provided to the input pins, it is possible that an internal input level may be generated due to noise, etc., hence causing malfunction. CMOS device behave differently than Bipolar or NMOS devices. Input levels of CMOS devices must be fixed high or low by using a pull-up or pull-down circuitry. Each unused pin should be connected to V_{DD} or GND with a resistor, if it is considered to have a possibility of being an output pin. All handling related to the unused pins must be judged device by device and related specifications governing the devices.

③ STATUS BEFORE INITIALIZATION OF MOS DEVICES

Note: Power-on does not necessarily define initial status of MOS device. Production process of MOS does not define the initial operation status of the device. Immediately after the power source is turned ON, the devices with reset function have not yet been initialized. Hence, power-on does not guarantee out-pin levels, I/O settings or contents of registers. Device is not initialized until the reset signal is received. Reset operation must be executed immediately after power-on for devices having reset function.